

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants :	Sun-Uk Kim et al.	Art Unit :	1791
Serial No. :	10/560,023	Examiner :	Erin Lynn Snelting
Filed :	December 8, 2005	Conf. No. :	1005
Title :	Method For Fabricating A Porous Silica Sphere		

MAIL STOP AF

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

SUPPLEMENTAL REPLY TO FINAL ACTION OF NOVEMBER 13, 2009

Please amend the above-identified application as follows: